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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/455,991	12/06/1999	HISASHI OHTANI .	07977/213002	5835
26171 · 75	590 02/10/2004	•	EXAMINER	
	IARDSON P.C.		DIAZ, JOSE R	
1425 K STREE	T, N.W.		ART UNIT	PAPER NUMBER
	N, DC 20005-3500	•	· 2815	

DATE MAILED: 02/10/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

			7/1
	Application No.	Applicant(s)	
	09/455,991	OHTANI ET AL.	
Office Action Summary	Examiner	Art Unit	
	José R Díaz	2815	
The MAILING DATE of this communication a	appears on the cover sheet	with the correspondence address -	•=
A SHORTENED STATUTORY PERIOD FOR REI THE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a  - If NO period for reply is specified above, the maximum statutory perions  - Failure to reply within the set or extended period for reply will, by state Any reply received by the Office later than three months after the material patent term adjustment. See 37 CFR 1.704(b).	N. t 1.136(a). In no event, however, may reply within the statutory minimum of t iod will apply and will expire SIX (6) M atute, cause the application to become	a reply be timely filed hirty (30) days will be considered timely. ONTHS from the mailing date of this communica ABANDONED (35 U.S.C. § 133).	ation.
Status			
1) Responsive to communication(s) filed on 25  2a) This action is <b>FINAL</b> . 2b) T  3) Since this application is in condition for allow closed in accordance with the practice under	his action is non-final. wance except for formal m		s is
Disposition of Claims		,	
4)  Claim(s) 6-12,14-16,18,20,21 and 23-71 is/a 4a) Of the above claim(s) is/are without 5)  Claim(s) is/are allowed. 6)  Claim(s) 6-12,14-16,18,20,21 and 23-71 is/a 7)  Claim(s) is/are objected to. 8)  Claim(s) are subject to restriction and Application Papers  9)  The specification is objected to by the Example 10)  The drawing(s) filed on is/are: a)  and applicant may not request that any objection to the Replacement drawing sheet(s) including the content of the cont	drawn from consideration.  fare rejected.  d/or election requirement.  niner.  accepted or b) objected  the drawing(s) be held in abey rection is required if the drawi	to <b>by the Examiner.</b> vance. See 37 CFR 1.85(a). ng(s) is objected to. See 37 CFR 1.12	
Priority under 35 U.S.C. § 119			
12) ☑ Acknowledgment is made of a claim for fore  a) ☑ All b) ☐ Some * c) ☐ None of:  1. ☐ Certified copies of the priority docume  2. ☑ Certified copies of the priority docume  3. ☐ Copies of the certified copies of the papplication from the International Bur  * See the attached detailed Office action for a second content of the papplication from the International Bur	ents have been received. ents have been received in priority documents have be reau (PCT Rule 17.2(a)).	Application No. <u>08/998964</u> . en received in this National Stage	
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper N	w Summary (PTO-413) lo(s)/Mail Date of Informal Patent Application (PTO-152)	
<ol> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/ Paper No(s)/Mail Date</li> </ol>	6) Other:		

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#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 3. Claims 6-12, 14-16, 18, 20-21, and 23-71 are still rejected under 35 U.S.C. 103(a) as being unpatentable over (specifically "Description of the Related Art" on pages 1-4 of the specification) in view of Zhang et al. (US Pat. No. 5,529,937), previously cited on Paper No. 3.

Regarding claims 6, 9, 23, 31, 39, 55, and 63, Applicant acknowledges a well-known method comprising the steps of: forming an amorphous semiconductor film (see page 1, lines 24-26) on an substrate (see page 1, lines 11-13); providing a metal element (811, 812) capable of promoting crystallization of the amorphous

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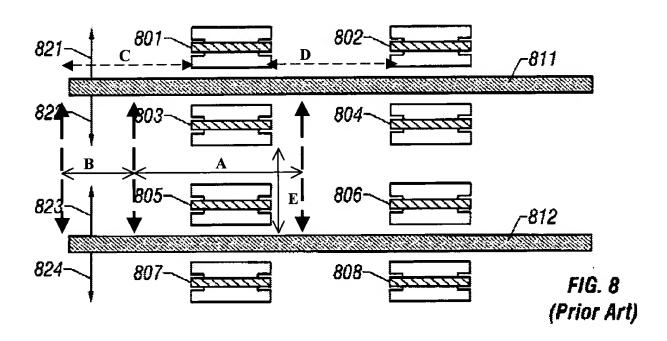
semiconductor film to form a first metal element added region (811) and a second metal element added region (812) (see fig. 8, below); crystallizing the amorphous semiconductor film so that a crystal growth (822, 823) proceeds in a crystal growth direction parallel to the insulating surface to form first and second crystalline portion (see regions A and B between the metal element 811 and 812 in Fig. 8, below); patterning the crystalline semiconductor film to form at least one crystalline island or active region (803) using only the first crystalline portion (see region A between the metal element 811 and 812 in Fig. 8, below); wherein the first metal element added region (811) is away from the second metal element added region (812); wherein carrier move in the crystalline semiconductor island (803) in a carrier moving direction identical with the crystal growth direction (822, 823) (see page 4, lines 9-11 and fig. 8, below); wherein the second metal element added region (812) is located apart from the crystalline semiconductor island (803) by a distance (E) (see Fig. 8, below); wherein the first metal element added region (811) has a length extending longer from an end portion of the crystalline semiconductor island (803) in a longitudinal direction of the first metal element added region (consider the portion of the metal element (811) that is between the end side of the region (B) and the end side of the crystalline semiconductor island (803) in Fig. 8, below).

However, applicant in the "Description of the Related Art" is silent with respect to the limitation of forming the amorphous semiconductor film on an insulating surface. Zhang et al. teaches that it is well known in the art to form an amorphous layer (104) over an insulating layer (102) (see fig. 1b). Applicant and Zhang et al. are analogous art

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because they are from the same field of endeavor as applicant's invention. At the time of the invention it would have been obvious to a person of ordinary skill in the art to form the amorphous layer over an insulating surface. The motivation for doing so, as is taught by Zhang et al., is to provide a protective film over the substrate (col. 8, lines 24-26). Therefore, it would have been obvious to combine applicant with Zhang et al. to obtain the invention of claims 6-12, 14-16, 18, 20-21, and 23-71.



Regarding claims 8, 10, 25, 33, 41, 49, 57 and 65, Applicant acknowledges that the metal element comprises at least Ni (811, 812) (see page 3, line 21 of specification).

Regarding claims 11-12, 26-27, 34-35, 42-43, 50-51, 58-59 and 66-67, Zhang et al. teaches that it is well known in the art to introduced the metal element by an ion implantation or by coating a solvent (see col. 11, lines 21-35). The motivation for

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introducing the metal element by ion implantation or by coating a solvent is to introduce a catalyst element, which promotes the crystallization of the amorphous layer (col. 5, lines 58-65).

Regarding claims 14, 18, 28, 36, 44, 52, 60 and 68, applicant acknowledges that the amorphous semiconductor film comprises silicon (see page 3, lines 22-24).

Regarding claims 7, 24, 32, 40, 47-48, 56, 64, and 71, applicant and Zhang et al., as stated before, teaches the claimed method (see rejection of claim 6, above). In addition, applicant acknowledges that the lengths (C, D) of the first metal element added region (811) and the second element added region (812) is about twice the length of 801 or 803 region, see Fig. 8, above). With regards to the limitations of a length of 100 μm or more, and a length of 50% or more of a crystal growth distance, it would have been obvious to one of ordinary skill in the art, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or working ranges involves only routine skill in the art. *In re Huang*, 40 USPQ2d 1685,1688(Fed. Cir. 1996) citing *In re Aller*, 105 USPQ 233., 235 (CCPA 1955).

Regarding claims 15-16, 20-21, 29-30, 37-38, 45-46, 53-54, 61-62 and 69-70, Applicant acknowledges that at least one of the transistors (803) formed by the method disclosed in the *Description of the Related Art* "has characteristics suitable for high-speed operation" (see page 4, lines 9-11). With regards to the claimed S value, it would have been obvious to one of ordinary skill in the art, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum

or working ranges involves only routine skill in the art. In re Huang, 40 USPQ2d 1685,1688(Fed. Cir. 1996) citing *In re Aller*, 105 USPQ 233., 235 (CCPA 1955).

### Response to Arguments

4. Applicant's arguments filed November 25, 2003 have been fully considered but they are not persuasive.

With regards to the "dummy metal regions", it is noted that nowhere in the claims Applicant recites such "dummy metal regions." As a matter of fact, Applicant only claims the formation of "a first metal element added region" and "a second metal element added region", which both are taught in figure 8 of Applicant's admitted prior art as regions 811 and 812.

With regards to the first and second crystalline portions, Applicant is advised that during patent examination, the pending claims must be "given the broadest reasonable interpretation consistent with the specification" (see MPEP 2111). In the instance case, the term "portion" is interpreted as to be any region formed between the metal element 811 and 812. For example, figure 8, as stated in the Office action mailed September 9, 2003, shows the formation of "a first crystalline portion" (A) and "a second crystalline portion" (B) (please note that both portions A and B are located between the metal elements 811 and 812, and only portion A includes the region in which the at least one crystalline island, i.e. 803, is formed).

With regards to the limitations about the length of 50% or more of a crystal growth distance, and the length of about 100 µm or more, please note that figure 8

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discloses that the metal added regions (811, 812) are further extended from an end portion of the crystalline semiconductor islands (803-806), which appear to have the same length dimension than the extended portion of the "dummy metal regions" 701/702 of figure 7. Thus, the claimed length range is merely an optimization of the teaching provided by figure 8. Therefore, it would have been obvious to one of ordinary skill in the art, since it has been held that where the general conditions of a claim are disclosed in the prior art, discovering the optimum or working ranges involves only routine skill in the art. In re Huang, 40 USPQ2d 1685,1688(Fed. Cir. 1996) citing In re Aller, 105 USPQ 233., 235 (CCPA 1955).

Accordingly, the rejection under 35 USC § 103 is considered to be proper.

#### Conclusion

5. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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Correspondence

6. Any inquiry concerning this communication or earlier communications from

the examiner should be directed to José R Díaz whose telephone number is (703) 308-

6078 or (571) 272-1727, after February 9, 2004. The examiner can normally be

reached on 9:00-5:00 Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Tom Thomas can be reached on (703) 308-2772. The fax phone number

for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is (703) 308-

0956.

JRD

10m / Nouns

Tom Thomas

Supervisory Patent Examiner Touhat 'one Center 2800